Mean volume reflection angle

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The mean volume reflection angle of a high-energy charged particle passing through a bent crystal is expressed as an integral involving the effective interplanar potential over a single crystal period. Implications for positively and negatively charged particles, and silicon crystal orientations (110) and (111) are discussed. A generic next-to-leading-order expansion in the ratio E/R of the particle energy E to the crystal bending radius R is given. For positively charged particles, the dependence of the mean volume reflection angle on E/R proves to be approximately linear, whereas for negatively charged particles the linear behavior is modified by an E/R-dependent logarithmic factor. Up-to-date experimental data are confronted with predictions based on commonly used atomic potentials.

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I. INTRODUCTION

Volume reflection (VR) is deflection of high-energy charged particles by a planarly oriented bent crystal. It may be regarded as an effect complementary to channeling in bent crystals, in which particles deflect to the side opposite to that of the crystal bending, whereas channeled particles deflect towards the crystal bending. It is considered to be applicable for beam steering at multi-GeV accelerators (e.g., in a multiple-VR mode), having the merit of high acceptance (see [1] and references therein). By now, it has been experimentally explored for various bent crystal orientations, incident charged particle types and beam energies [2–11].

The VR effect owes to the asymmetry of the effective continuous potential of atomic planes caused by the crystal bending, but it does not vanish when this asymmetry becomes small. On the contrary, in that case it becomes maximal. Its theoretical treatment is facilitated by the fact that if, as is normally the case, the bending is sufficiently uniform, then the particle angular momentum (or transverse energy) in the effective potential with a centrifugal component is conserved [12]. That makes the problem integrable and in principle analytically tractable [13–19]. However, since the VR angle is accumulated over many interplanar intervals, in each of which the centrifugal potential component is different, yet the interplanar potential itself is

generally given by a sophisticated function, the VR angle dependencies on the particle energy and charge sign, crystal material, orientation and bending radius are obscured, ultimately demanding numerical evaluation.

To get a grasp of various parameter dependencies in the VR problem, in [15] it was solved for the simplest example—a parabolic model for the interplanar potential. It was demonstrated that the complicated dependencies of the VR angle on R and E greatly simplify if an expansion in the small parameter R_c/R [with $R_c(E)$ being the critical radius] is carried out. With its aid, explicit expressions for the VR angle of positively and negatively charged particles were obtained. But the model treatment was only adequate for silicon crystal in orientation (110), and did not cover other practically important cases, such as silicon in orientation (111), and germanium crystals.

The aim of the present paper is to generalize the analytic theory of VR, and develop theoretical tools valid for arbitrary interplanar potential and any crystal orientation. To this end, it is expedient to interchange the procedures of radial integration and averaging over the transverse energy, which leads to an expression for the VR angle as an integral over a single crystal period of a square root of the effective potential. With its aid, a generic expansion in R_c/R can be derived, in which the entire dependence on the straightcrystal potential enters to the coefficient functions. Cases of $R \sim R_c$ and $R \to R_c$ can be studied, as well.

For simplicity, herein we restrict ourselves to the thickcrystal limit, when contributions from the crystal boundaries are vanishing, and presume the so-called statistical equilibrium, i.e., a uniform distribution in the fast particle transverse energy [13]. Furthermore, we will focus on issues most important for practice, i.e., calculation of the mean VR angle, which is often directly extracted from the

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experimental data, being almost unaffected by incoherent multiple scattering, and application to silicon crystals, usually used in experiments.

In order to assess the accuracy of the obtained exact and approximate representations, we confront their predictions based on popular realistic potentials with the up-to-date world data for bent silicon crystals in orientations (110) and (111), and for both particle charge signs. For the benefit of the reader, we also include a summary of results for a few model potentials, qualitatively illustrating dependencies on their typical parameters.

II. GENERAL CONSIDERATIONS

When a fast charged particle traverses a bent crystal, the angle θ between its velocity and the family of weakly bent and long atomic planes gradually changes. At its relatively small values, relevant for the VR effect, the particle motion is governed by relativistic classical mechanics in the continuous potential averaged along the planes, similarly to the case of channeling. The period of the force acting on the particle is then tapering to both sides away from the VR region, and in remote regions, in which $|\theta| \gg \theta_c$, where $\theta_c = \sqrt{2V_0/E}$ is the critical channeling angle for a straight crystal with well depth V_0 , its net deflecting action tends to zero. As for the incoherent multiple scattering, its strength per unit particle path length remains nearly constant everywhere in the crystal (an *R*-dependent correction to it was evaluated in [16,17]), so, in a thick crystal it eventually becomes formidable. But within the intrinsic VR region, it still remains minor compared to the action of the continuous potential. Besides that, the incoherent multiple scattering is symmetric with respect to the initial particle motion direction. Therefore, in the first approximation it should not contribute to the mean VR angle, and may be neglected.

As was pointed out already in paper [12], where VR was predicted, basic notions facilitating the theoretical description of VR are the same as for channeling in a bent crystal [20]:

- 1. The continuous potential of a uniformly bent crystal in a planar orientation is axially symmetric. Thus, it conserves the angular momentum projection on the symmetry axis, or, equivalently, the transverse energy including the centrifugal potential. This second integral of the two-dimensional motion (excluding the irrelevant uniform motion along the crystal bending axis and the planes) makes the problem completely integrable.
- 2. For a small crystal bending angle (not damaging the ideal crystal lattice), the centrifugal potential may be linearized within the entire crystal volume.

The particle trajectory in polar coordinates $\{r, \varphi\}$ (radius and angle with respect to the bent crystal symmetry axis, located far outside of the crystal) then expresses in an explicit integral form [12]:

$$\varphi(r, r_0, E_{\perp}) = \frac{1}{R} \int_r^{r_0} \frac{dr}{\sqrt{2\frac{E_{\perp} - V(r)}{E} + 2\frac{r}{R}}}.$$
 (1)

Here *R* designates the crystal bending radius, *E* the energy of the fast particle (assumed to be ultrarelativistic¹), E_{\perp} the particle transverse energy (defined here to include all the *r*-independent terms), V(r) the periodic (with period *d*) continuous potential of the corresponding family of atomic planes, which in a uniformly bent crystal depends only on the radial coordinate *r* normal to the planes, and r_0 is the *r* value at the particle entrance to the crystal.

Equation (1) serves as a starting point for all the subsequent calculations. Pure VR experiments, though, measure not the entire particle trajectory inside the crystal, but only the final deflection angle. It can be deduced from (1) as² [13]

$$\chi(r_0, E_{\perp}) = \frac{2}{R} \int_{r_c}^{r_0} dr \Biggl\{ \frac{1}{\sqrt{2\frac{E_{\perp} - V(r_c)}{E} + 2\frac{r}{R}}} -\frac{1}{\sqrt{2\frac{E_{\perp} - V(r)}{E} + 2\frac{r}{R}}} \Biggr\},$$
(2a)

where r_c is the radial reflection point, in which $\frac{E_{\perp}-V(r_c)}{E} + \frac{r_c}{R} = 0$, and the factor of 2 in Eq. (2a) accounts for contributions before and after the radial reflection, assuming the crystal to be oriented symmetrically with respect to the beam direction. If the first term in the braces in Eq. (2a) is integrated explicitly [15,18], viz.,

$$\chi = 2\sqrt{2\frac{E_{\perp} - V(r_0)}{E} + 2\frac{r_0}{R}} - \frac{2}{R}\int_{r_c}^{r_0} \frac{dr}{\sqrt{2\frac{E_{\perp} - V(r)}{E} + 2\frac{r}{R}}},$$
(2b)

it is evident that the first term

$$2\sqrt{2\frac{E_{\perp} - V(r_0)}{E} + 2\frac{r_0}{R}} = 2\frac{dr_0}{Rd\varphi}$$

represents the doubled angle between the particle velocity $d\vec{r}/dt$ (with time differential $dt = Rd\varphi$) and the bent aligned atomic planes at the exit from the crystal, whereas the second

¹In a generic case, *E* in Eq. (1) must be replaced by Ev^2/c^2 , where *v* is the particle velocity and *c* the speed of light, but insofar as VR is usually applied to ultrarelativistic particles, for brevity we neglect the difference between *v* and *c*. For non-ultrarelativistic particles, the corresponding substitution is due in the final equations.

²Compared to [13,15], we define here angle χ of deflection with respect to the initial particle direction of motion with the opposite sign, in order to make it positive. Notations θ and θ_c are reserved for angles of particle motion with respect to atomic planes.

term—the polar angle φ subtended by the particle trajectory in the crystal, i.e., in effect, the total crystal bending angle. Their difference, naturally, equals the deflection angle in the inertial laboratory frame.

Next, it needs to be taken into account that in practice, the initial state represents not a single particle with a perfectly known impact parameter and velocity, but a beam. Particles from the incident beam enter the crystal with random (at an atomic scale) impact parameters and with slightly randomized angles. Accordingly, E_{\perp} is a randomly distributed variable, too. One has therefore to derive from (2) the angular distribution of the scattering probability. Its calculation is alleviated [13] by relying on the so-called "statistical equilibrium" property, i.e., a uniform distribution in E_{\perp} within the relatively small (compared with the initial E_{\perp} uncertainty)³ period $\Delta E_{\perp} = Ed/R$:

$$\frac{dw}{d\chi} = \frac{1}{\Delta E_{\perp}} \frac{dE_{\perp}}{d\chi}.$$
(3)

Therewith, the mean VR angle, on which we will focus in the present paper, is given by a simple expression:

$$\overline{\chi} = \int d\chi \frac{dw}{d\chi} \chi$$
$$= \frac{1}{\Delta E_{\perp}} \int_{\text{const}}^{\text{const}+\Delta E_{\perp}} dE_{\perp} \chi(E_{\perp}), \qquad (4)$$

directly in terms of $\chi(E_{\perp})$ rather than its inverse function entering Eq. (3). The constant in the integration limits may be arbitrary, as long as the $\chi(E_{\perp})$ dependence is periodic with the period ΔE_{\perp} , and the integration is carried out over the full period.

Although VR is supposed to be formed deeply inside the bent crystal, in principle, integral (2) has yet some residual dependence on its end points. The latter, however, fades away with the increase of the target thickness. If, to the leading order in thickness, this dependence is neglected, there remains the genuine volume contribution. Formally, it expresses as a thick-crystal limit:

$$\chi = 2 \lim_{r_0 \to \infty} \left\{ \sqrt{2 \frac{r_0}{R}} - \frac{1}{R} \int_{r_{\min}(E_{\perp})}^{r_0} dr \sqrt{\frac{E}{2[E_{\perp} - V_{\text{eff}}(r)]}} \right\}.$$
 (5)

Here

$$V_{\rm eff}(r) = V(r) - \frac{Er}{R} \tag{6}$$

is the effective potential of the bent crystal, which has a "washboard" shape due to a tilt introduced by the linearized centrifugal potential component (see Fig. 1). The difference

in the braces in Eq. (5) converges on a transverse spatial scale $\Delta r \sim RV_0/E = R\theta_c^2/2$ corresponding to

$$\Delta z \sim \sqrt{2R\Delta r} \sim R\theta_c. \tag{7}$$

This longitudinal scale must be smaller than the crystal thickness $L = R\theta_b$, where θ_b is the crystal bending angle:

$$L \gg \Delta z$$
, i.e., $\theta_b \gg \theta_c$. (8)

The crystals for VR are usually designed to meet the latter requirement. By virtue of the mentioned convergence at large r_0 , Eq. (5) holds equally well for cases when the VR region is not strictly in the middle of the crystal.

For a periodic V(r), the integrand in (5) is not periodic in *r*. But granted the simplicity of its dependence on the period number, it is feasible to sum over the entire sequence of periods in closed form [21]. That leads to a generic representation for the VR angle as an integral over a single interplanar period with the integrand given by a generalized Riemann zeta function [22] (see also [15,17]) with parameter 1/2 and the argument depending on $V_{\text{eff}}(r)$:

$$\chi = -\frac{2}{\sqrt{2Rd}} \int_0^d dr \Re e\zeta \left(\frac{1}{2}, \frac{R}{d} \frac{E_\perp - V_{\text{eff}}(r)}{E}\right). \quad (9)$$

Substitution thereof to Eq. (4) leads to further simplifications, and yields an expression for the mean VR angle involving no special functions:

$$\sqrt{\frac{E}{2}}\frac{d}{2}\overline{\chi}(E,R) = \int_0^d dr \sqrt{\max_{r' \ge r} V_{\text{eff}}(r') - V_{\text{eff}}(r)}, \quad (10)$$

where $\max_{r' \ge r} V_{\text{eff}}(r')$ is the global maximum in the semiinfinite region $r \le r' < \infty$, thus being unique (see Fig. 1), in contrast to possible minor local maxima. Formula (10) can also be derived directly, bypassing evaluation of the



FIG. 1. Solid curve, effective potential $V_{\text{eff}}(r)$ of a bent crystal. Its red regions signify loci of radial reflection points of VR particles coming from and returning to $r \to +\infty$ with a constant E_{\perp} . Red curve segments combined with the horizontal dotted lines show behavior of function $\max_{r' \ge r} V_{\text{eff}}(r')$. Thick green curve segments mark intervals contributing to the mean VR angle.

³For a more detailed analysis of conditions of its validity, see [15].

angular (or E_{\perp}) distribution, as is demonstrated in the Appendix A.

The integrand in Eq. (10) differs from zero only in regions $V_{\text{eff}}(r) < \max_{r' \ge r} V_{\text{eff}}(r')$, marked in Fig. 1 by green. Paradoxically, those are the regions usually associated with channeled particles, whereas VR particles, being overbarrier, on the contrary, radially reflect in the regions marked in Fig. 1 by red. Nonetheless, the latter regions do not contribute to the mean VR angle at all. One of the consequences is that $\overline{\chi}$ must strictly vanish for $R \le R_c$ [where R_c by definition is the smallest value of R, at which $V_{\text{eff}}(r)$ has local minima, and hence maxima], insofar as in that case $V_{\text{eff}}(r)$ has no maxima. That is, VR exists under the same condition,

$$R > R_c, \tag{11}$$

as channeling in a bent crystal, but pertains to overbarrier particles. That agrees with the former results of numerical evaluation of integral (2a) in [19] (see also [23]). It is also evident that the integrand of (10) is everywhere positive, so the net deflection always proceeds to the side opposite to that of the crystal bending. As was mentioned in the Introduction, that is the distinguishing feature of VR.

In a periodic continuous potential, all of whose wells are equivalent [such as the potential of a silicon crystal in orientation (110)], it is convenient to choose the integration interval end point coinciding with location of any of the maxima r_m of the effective potential: $\max_{r' \ge r} V_{\text{eff}}(r') = V_{\text{eff}}(r_m)$. For such a choice, $\max_{r' \ge r} V_{\text{eff}}(r')$ does not depend on r within the entire part of integration interval, where the radicand is greater than zero. Moreover, the integration may be extended over the entire crystal period, provided the region where the radicand turns negative (and the integrand imaginary) is eliminated by taking the real part:

$$\sqrt{\frac{E}{2}} \frac{d}{2} \overline{\chi}(E, R) = \int_{r_m-d}^{r_m} dr \Re e \sqrt{V_{\text{eff}}(r_m) - V_{\text{eff}}(r)}.$$
 (12)

That obviates the need for independent maximization of V_{eff} for every value of r in the integrand.

In a more complicated case, when the continuous potential contains two inequivalent wells per period, as it is known to be, e.g., for positively charged particles in a silicon crystal in orientation (111) [see Fig. 5(b)], it suffices to split the integration interval in two parts by the intermediate maximum:

$$\sqrt{\frac{E}{2}} \frac{d}{2} \overline{\chi}(E, R) = \int_{r_{m2}-d}^{r_{m1}} dr \Re e \sqrt{V_{\text{eff}}(r_{m1}) - V_{\text{eff}}(r)} + \int_{r_{m1}}^{r_{m2}} dr \Re e \sqrt{V_{\text{eff}}(r_{m2}) - V_{\text{eff}}(r)}.$$
 (13)

The subsequent calculation procedure for each of the latter partial integrals is the same as for integral (12) for a singlewell potential. It is also possible [e.g., for negatively charged particles and crystal orientation (111), corresponding to Fig. 5(b) flipped upside down] that at small E/R the potential is of single-well type, while with the increase of E/R it becomes double-well. In that case, at the critical E/R value one must switch from formula (12) to (13).

Formulas (12) and (13) are well suited both for numerical evaluation of the mean VR angle and for analysis of the intrinsic E and R dependencies. The latter will be the subject of the next three sections. Phenomenological issues are discussed in Sec. VI.

III. SMALL- R_c/R EXPANSION

For a given oriented crystal, i.e., given V(r), the rhs of Eq. (10) depends on the experimentally changeable parameters E and R only via the ratio E/R, representing the centrifugal force. For any shape of the interplanar potential, the increase of centrifugal force E/R makes the effective potential well progressively more tilted and shallower, wherewith the mean reflection angle (12) decreases. Vice versa, its maximal value is achieved in the formal straight-crystal limit⁴ $R \rightarrow \infty$. That is the second salient feature of VR mentioned in the Introduction. Since the case of small R_c/R , when $\overline{\chi}$ is maximal, is of the highest practical value, we will analyze it in the first place.

A. Leading order in R_c/R

To evaluate the maximal value of $\overline{\chi}$ achieved at $R \to \infty$, one needs merely to replace in Eq. (10) the effective potential by the real one:

$$\lim_{R \to \infty} \overline{\chi} = \chi_0 = \sqrt{\frac{2}{E}} \frac{2}{d} \int_0^d dr \sqrt{\max V - V(r)}.$$
 (14)

Since the integrand in the right-hand side of Eq. (14) is a periodic function of r, it does not matter where to choose the integration limits of an interval of the length d.

The obtained result can be cast in a more intuitive form:

$$\chi_0 = 2 \langle \theta_c(r) \rangle_r, \tag{15}$$

where

$$\theta_c(r) = \sqrt{2[\max V - V(r)]/E}$$
(16)

is the "local" critical angle (for a straight crystal) sensed by the overbarrier particle during its passage through the

⁴Throughout this paper, we assume the incoherent multiple scattering effect on $\overline{\chi}$ to be negligible, despite the expanding intrinsic VR region (7)—see conditions (93) and (95) below. The mentioned limit thus must be understood in the sense of extrapolation. Since *R* is a dimensional quantity, condition $R \rightarrow \infty$ must be understood in the present context as $4R_c/R \ll 1$ or $\frac{Ed}{V_{oR}R} \ll 1$.

interplanar interval with a nearly critical transverse energy, and $\langle \cdots \rangle_r = \frac{1}{d} \int_0^d dr \dots$ designates averaging over the continuous potential period. The factor of 2 in Eq. (15) may be interpreted as accounting for contributions from particle motion before and after the reflection point. A corollary from Eq. (15) is that

$$\chi_0 \le 2 \max \theta_c(r) \equiv 2\theta_c. \tag{17}$$

However, in practice, R is never so large compared to R_c that the difference between $\overline{\chi}$ and χ_0 is really negligible. Thus, at least a first-order E/R-dependent correction to χ_0 should be taken into account. Its derivation and refinements are discussed below.

B. Next-to-leading order in R_c/R

Since Eq. (13) reduces the problem for a two-well periodic continuous potential to that for a single-well one, we begin with the most elementary case when the generic solution is given by formula (12).

To derive from it the next-to-leading order (NLO) correction to (14), note that in Eq. (12) the dependence on E/R enters both to $V_{\text{eff}}(r)$ and $V_{\text{eff}}(r_m)$, where r_m depends on E/R, too. If V(r) has maxima at r = 0 and r = d, the effective potential maximum location r_m may be chosen to be close to d. In its vicinity,

$$V_{\text{eff}}(r) \underset{r \approx d}{\simeq} \max V - \frac{(r-d)^2}{2} |V''(d)| - \frac{E}{R}r$$

= $\max V - \frac{Ed}{R} - \frac{(r-r_m)^2}{2} |V''(d)| + \mathcal{O}\left(\frac{E^2}{R^2}\right),$ (18)

where we took into account that V'(d) = 0. Hence, the potential maximum location shifted by the centrifugal tilt equals

$$r_m = d - \frac{E}{R|V''(d)|} + \mathcal{O}\left(\frac{E^2}{R^2}\right).$$

This allows to determine the corresponding effective potential maximal value:

$$V_{\text{eff}}(r_m) = \max V - \frac{Ed}{R} + \mathcal{O}\left(\frac{E^2}{R^2}\right),$$

which proves to be independent of V''(d) in this approximation. Therefore, to the NLO, i.e., omitting all the $\mathcal{O}(E^2/R^2)$ contributions, all the linear E/R dependence in (12) reduces to a term $\frac{E}{R}(r-d)$ in the radicand:



FIG. 2. Solid curve, the integrand of Eq. (12) for a tilted singlewell periodic potential. Dashed curve, the $R_c/R \rightarrow 0$ limit of the integrand. The area under it is the LO contribution [Eq. (14)]. The small area between the solid and the dashed curves at small R_c/R may be regarded as the NLO contribution.

$$\sqrt{\frac{E}{2}} \frac{d}{2} \overline{\chi} = \Re e \int_0^d dr \sqrt{\max V - V(r) + \frac{E}{R}(r-d)} + \mathcal{O}\left(\frac{E^2}{R^2}\right).$$
(19)

The change in the integrand compared with the leadingorder (LO) Eq. (14) is illustrated in Fig. 2.

Next, linearizing the entire integrand in E/R and integrating the result termwise, we get

$$\sqrt{\frac{E}{2}} \frac{d}{2} \overline{\chi} \simeq \int_{0}^{d} dr \sqrt{\max V - V(r)} + \frac{E}{2R} \int_{0}^{d} dr \frac{r - d}{\sqrt{\max V - V(r)}}.$$
 (20)

It involves only the potential for a straight crystal. Since a single-well potential of a straight crystal must be symmetric with respect to its minimum at r = d/2, Eq. (20) may be recast as

$$\overline{\chi} \simeq \sqrt{\frac{2}{E}} \frac{4}{d} \int_0^{d/2} dr \sqrt{\max V - V(r)} -\frac{\sqrt{2E}}{R} \int_0^{d/2} \frac{dr}{\sqrt{\max V - V(r)}}$$
(21a)

$$\equiv \chi_0 - \frac{d}{R} \left\langle \frac{1}{\theta_c(r)} \right\rangle_r.$$
(21b)

Equation (21a) demonstrates that the deeper on the average the potential well, or, for a fixed depth, the more rectangular it is, the larger is the LO contribution (the first term), and the smaller by absolute value the negative NLO contribution (the second term). Hence, larger VR angles (beneficial for beam steering applications) are achieved for crystal materials with higher Z and orientations with wider interplanar intervals.

To invariantly relate the $\overline{\chi}(E, R)$ dependence in the NLO with the shape of the potential well, one can introduce a product

$$K = \frac{\sqrt{E}}{2d} \chi_0 \left| \frac{d(\sqrt{E\overline{\chi}})}{d(E/R)} \right|_{E/R \to 0} = \frac{\chi_0}{2d} \left| \frac{\partial \overline{\chi}}{\partial (1/R)} \right|_{R \to \infty}$$
(22a)

$$= \langle \theta_c(r) \rangle_r \left\langle \frac{1}{\theta_c(r)} \right\rangle_r$$

$$\equiv \langle \sqrt{\max V - V(r)} \rangle_r \left\langle \frac{1}{\sqrt{\max V - V(r)}} \right\rangle_r, \qquad (22b)$$

which, according to the Cauchy-Bunyakovsky-Schwarz inequality, must be greater than unity:

$$K \ge 1 \tag{23}$$

for any V(r). The smaller (the closer to unity) this number, the closer the well shape to rectangular.

It should be minded, however, that Eq. (22b) and inequality (23) have been established only for a singlewell potential, and only provided $\int_0^{d/2} \frac{dr}{\sqrt{\max V - V(r)}}$ converges, by virtue of which the integration may be extended over the full interplanar interval. Otherwise, notably, for multiwell potentials, the rhs of (22a) may become smaller than unity, because in the limit $R_c/R \rightarrow 0$ not all the particles completely traverse the last interplanar interval, being reflected in different subwells (see examples in Sec. III below).

For a double-well periodic potential, a similar analysis can be based on Eq. (13). Repeating the linearization procedure for each of the intervals, and presuming the symmetry of each subwell (which must hold since inversion with respect to each subwell center leaves the periodic sequence of atomic planes invariant), one is led to the result

$$\overline{\chi} \simeq \chi_0 - \frac{\sqrt{2E}}{R} \left(\frac{d_1}{d_1 + d_2} \int_0^{d_1/2} \frac{dr}{\sqrt{\max V - V(r)}} + \frac{d_2}{d_1 + d_2} \int_{d_1}^{d_1 + d_2/2} \frac{dr}{\sqrt{\max V - V(r)}} \right)$$
(24a)

$$=\frac{2}{d}(d_1\langle\theta_c\rangle_1 + d_2\langle\theta_c\rangle_2) - \frac{1}{Rd}\left(d_1^2\left\langle\frac{1}{\theta_c}\right\rangle_1 + d_2^2\left\langle\frac{1}{\theta_c}\right\rangle_2\right),$$
(24b)

where $\langle \cdots \rangle_1 = \frac{1}{d_1} \int_0^{d_1} dr \dots$, $\langle \cdots \rangle_2 = \frac{1}{d_2} \int_{d_1}^{d} dr \dots$ For $d_1 = 0$ or $d_2 = 0$, as well as for $d_1 = d_2 = d/2$, this goes over to Eq. (21).

C. Logarithmic modification of NLO term

Unfortunately, the applicability of simple formula (21) in practice is undermined because the difference max V - V(r) at the tops of the barriers tends to zero quadratically, wherewith $\int_0^{d/2} \frac{dr}{\sqrt{\max V - V(r)}}$ diverges logarithmically. For

positively charged particles that happens due to thermal (and zero-point) fluctuations of atom positions in the planes. Granted that those fluctuations are relatively small, a finite result might be attained by just replacing in the NLO integral in Eq. (21) the interplanar potential by its static counterpart [i.e., letting u = 0 in Eq. (76) below]:

$$\overline{\chi} \simeq \chi_0 - \frac{\sqrt{2E}}{R} \int_0^{d/2} \frac{dr}{\sqrt{\max V_{\text{stat}} - V_{\text{stat}}(r)}}, \quad (25)$$

with

$$V_{\text{stat}}(r) = V(r)|_{u=0}.$$

Such an approximation should not be too unreasonable, because if the radial reflection point belongs to the region $r_c > u$, for all $r > r_c > u$ the difference between max $V_{\text{stat}} - V_{\text{stat}}(r)$ and max V - V(r) is small.

Alternatively, one may introduce in (21) an appropriate logarithmic cutoff $r_* \ll d/2$:

$$\overline{\chi} \simeq \chi_0 - \frac{\sqrt{2E}}{R} \int_{r_*}^{d/2} \frac{dr}{\sqrt{\max V - V(r)}}.$$
 (26)

Here, assuming the symmetry of the interplanar potential, we integrated only over half the period and multiplied by 2. The error due to the deliberateness of the choice of r_* may be relatively small.

For negatively charged particles, however, such an *ad hoc* cutoff approach may be too crude, because the round top of the potential barrier lies between the planes, being broad for any crystal temperature. In that case, to be rigorous, one should return to representation (19). It can be handled in the next-to-leading logarithmic order by splitting the integration interval in two parts, in the first of which, $0 < r < r_i \ll d$, the potential is approximable by its Taylor expansion around the maximum up to the quadratic term: $V(r) \simeq \max V + V''(0)r^2/2$, with V''(0) < 0, whereas in the second, $r_i < r < d$, it is already safe to expand the radicand to the NLO in R_c/R , as in Eq. (20):

$$\sqrt{\frac{E}{2}} \frac{d}{2} \overline{\chi} \simeq \Re \mathbf{e} \int_{0}^{r_{i}} dr \sqrt{\frac{|V''(0)|}{2}} r^{2} - \frac{Ed}{R} + \int_{r_{i}}^{d} dr \left[\sqrt{\max V - V(r)} + \frac{E(r-d)}{2R\sqrt{\max V - V(r)}} \right] + \mathcal{O}\left(\frac{E^{2}}{R^{2}}\right).$$
(27)

Computing those two integrals and eliminating r_i (see Appendix B), we are led to a form similar to (26),

$$\overline{\chi} \simeq \chi_0 - \frac{\sqrt{2E}}{R} \int_{r_*(E/R)}^{d/2} \frac{dr}{\sqrt{\max V - V(r)}}, \qquad (28)$$

with the difference that the lower cutoff is now unambiguously defined and centrifugal-force dependent:

$$r_*(E/R) = \sqrt{\frac{Ed}{2eR|V''(0)|}},$$
 (29)

where e = 2.718 is the base of a natural logarithm.

The obtained value of r_* is natural by the order of magnitude, because the corresponding drop of the potential near the top is commensurable with a typical centrifugal energy,

$$|V''(0)|\frac{r_*^2}{2} = \frac{Ed}{4eR} \sim \Delta E_\perp$$

Noteworthy, however, is a small numerical factor $\frac{1}{4e} \approx 0.1$. It corroborates our assumption that $r_* \ll d/2$, as long as

$$R_c = \frac{E}{F_{\max}} < \frac{2E}{|V''(0)|d} = \left(\frac{2r_*}{d}\right)^2 eR \ll R.$$

Thus, in the case when the particle reflects from the potential barrier in the region of its parabolic top, for description of the NLO correction it suffices to know only two empirical constants: V''(0) and

$$\lim_{r_* \to 0} \left(\int_{r_*}^{d/2} \frac{dr}{\sqrt{\max V - V(r)}} + \sqrt{\frac{2}{|V''(0)|}} \ln \frac{2r_*}{d} \right) \\
= \int_0^{d/2} dr \ln \frac{d}{2r} \frac{d}{dr} \frac{r}{\sqrt{\max V - V(r)}}$$
(30)

[see Eq. (B2)]. They can be computed numerically, given a realistic parametrization for the interplanar potential V(r).

Formula (28) with cutoff (29) is best suited for negatively charged particles, for which the round top of the potential barrier is wide, wherewith the Taylor expansion around its maximum works in a sufficiently broad interval of E/R, too. As for positively charged particles, for them the condition implied at derivation of Eq. (28) may be violated if the tilt proportional to E/R is so large that in the reflection point the continuous potential top is no longer parabolic. But even in that case, around the turnover point the distinction from the extended parabolic approximation for the potential top may be relatively mild (otherwise the NLO approximation itself can break down). Whether or not the logarithmic dependence along with cutoff prescription (29) survives under such conditions will be investigated in more detail on model examples in Sec. IV B 3 and for realistic potentials in Sec. VI.

If the potential has two inequivalent wells per period, with widths d_1 and d_2 , the derivation of the NLO formula must be based on Eq. (13). It gives

$$\overline{\chi} \simeq \chi_0 - \frac{\sqrt{2E}}{R} \left(\frac{d_1}{d_1 + d_2} \int_{r_{*1}}^{d_1/2} \frac{dr}{\sqrt{\max V - V(r)}} + \frac{d_2}{d_1 + d_2} \int_{d_1 + r_{*2}}^{d_1 + d_2/2} \frac{dr}{\sqrt{\max V - V(r)}} \right),$$
(31)

with

$$r_{*k}(E/R) = \sqrt{\frac{Ed_k}{2eR|V''(r_{mk})|}}, \qquad k = 1 \quad \text{or} \quad 2$$

IV. MODEL RESULTS

Even though the obtained generic solution (12) or (13) reduces the problem to an integral, which is sufficiently simply calculable numerically, it can be useful sometimes to refer also to model results, in which the dependencies of $\overline{\chi}$ on all the parameters are explicit. Models can also be used for testing the accuracy of the proposed generic approximations, such as the NLO expansion. They may be even more helpful when R becomes commensurable with the critical value R_c , so that the NLO approximation breaks down. But it is desirable in this case that the models reflect the shape of the interplanar potential adequately enough. In this section, for references, we will quote predictions for $\overline{\chi}$ for a few such model potentials, pertinent both to single-well and double-well cases.

A. Simple parabolic and square well potentials. Arbitrary R/R_c

Integral (12) can be taken in elementary functions only if V(r) is a linear or quadratic polynomial in r (with an exception considered in Sec. V). In fact, for silicon crystal in orientation (110) the parabolic approximation is known to be rather satisfactory. It is this approximation that was used in [15], but only for small R/R_c . More generally, if the effective potential is strongly tilted, only relatively small portions of the wells contribute to the mean VR angle (cf. Fig. 1). Then, if the potential varies smoothly enough, as is typical for moderate-Z crystal materials, it can be parametrized in those small regions by a quadratic polynomial. On the other hand, if the potential walls are steep, as is typical for high-Z materials, one can approximate them by square wells. It will be instructive first to analyze properties of those two simplest among exactly solvable models.

• For a sequence of parabolic wells of depth $V_0 > 0$, described within a period by the potential

$$V(r) = V_0 \left(\frac{2r}{d} - 1\right)^2, \qquad 0 < r < d, \quad (32)$$

serving as an idealization for the interplanar potential for positively charged particles in a silicon crystal in orientation (110), evaluation of integral (12) gives

$$\frac{\overline{\chi}}{\theta_c} = \frac{\pi}{2} \left(1 - \frac{R_c}{R} \right)^2 \tag{33}$$

with

$$R_c = \frac{E}{F_{\text{max}}} = \frac{Ed}{4V_0} \tag{34}$$

being the critical radius for this model. In the LO, $\chi_0 = \frac{\pi}{2}\theta_c$, while in the NLO, the squared binomial in Eq. (33) linearizes to

$$\frac{\overline{\chi}}{\theta_c} = \frac{\pi}{2} \left(1 - \frac{2R_c}{R} \right) + \mathcal{O}\left(\frac{R_c^2}{R^2}\right), \tag{35}$$

agreeing with the result of [15], as well as with the generic formula (21). The dimensionless parameter (22b) for this model equals

$$K = \frac{\pi^2}{8} = 1.234. \tag{36}$$

• For the sequence of parabolic barriers of height $V_0 > 0$, being an idealization for the continuous potential for negatively charged particles in silicon in orientation (110), the potential well has the form

$$V(r) = \begin{cases} -V_0(\frac{2r}{d})^2, & 0 < r < d/2, \\ -V_0\left(2\frac{d-r}{d}\right)^2, & d/2 < r < d. \end{cases}$$

Inserting this to Eq. (12), one obtains

$$\frac{\overline{\chi}}{\theta_c} = 1 - \frac{R_c}{R} \left(1 + \ln \frac{R}{R_c} \right), \tag{37}$$

where R_c is given by the same Eq. (34). For this model, $\chi_0 = \theta_c$, while $\frac{\chi_0}{2d} \left| \frac{\partial \overline{\chi}}{\partial (1/R)} \right|$ at $R_c/R \to 0$ retains a logarithmic dependence on R_c/R . The right-hand sides of both (33) and (37) at $R \to R_c$ tend to zero *quadratically*, because at $R \to R_c$ in integral (12) both the width and the height of the integrand $\Re e \sqrt{\max V_{\text{eff}} - V_{\text{eff}}(r)}$ tend to zero linearly. Formula (37) is exact, but follows as well from the generic NLO approximation (28) when setting there $V(r) \simeq \frac{1}{2}V''(0)r^2$ with $V''(0) = -8V_0/d^2$. All the corrections beyond the NLO in this model happen to vanish.

• In the opposite extreme of a square well, the potential within the period has a constant depth $V_0 > 0$, viz., $V(r) = -V_0$ within the interval 0 < r < d, and V = 0 at r = 0 and r = d.⁵ Then integral (12) evaluates to



FIG. 3. Mean VR angle dependence on E/R for several models for the periodic continuous potential with well depth V_0 and width *d*. Solid parabola, positively charged particles in a harmonic potential well [Eq. (33)]. Dashed curve, negatively charged particles in the same field [Eq. (37)]. Dot-dashed curve, the result for a square well interplanar potential, Eq. (38). Concerning the limit $E/R \rightarrow 0$, see footnotes 1 and 4.

$$\frac{\overline{\chi}}{\theta_c} = \frac{4RV_0}{3Ed} \left[1 - \Re e \left(1 - \frac{Ed}{RV_0} \right)^{3/2} \right], \quad (38)$$

which for $\frac{Ed}{RV_0} < 1$ matches with the result of [14] in the limit of zero barrier thickness $(a \rightarrow 0)$. The rhs of this expression as a function of R tends to zero (linearly) only at $R \rightarrow 0$, because for a square well $R_c = 0$. The linear law here reflects the fact that at $R \rightarrow R_c$ only the width of the effective potential well shrinks to zero, whereas its depth remains constant, being determined by the height of the sharp walls. Three terms of expansion of (38) read

$$\frac{\overline{\chi}}{\theta_c} = 2 - \frac{Ed}{2RV_0} - \frac{1}{3} \left(\frac{Ed}{2RV_0}\right)^2 + \mathcal{O}\left[\left(\frac{Ed}{RV_0}\right)^3\right].$$
 (39)

So, for this model, $\chi_0 = 2\theta_c$ [the upper bound of (17) is reached], and

$$K = 1 \tag{40}$$

[the lower bound of (23) is reached], because $\theta_c(r)$ here is just a constant. It is also noteworthy that for a square well, the next-to-next-to-leading order (NNLO) contribution to $\overline{\chi}$ is negative, whereas for the parabolic well, according to Eq. (33) expanded up to quadratic term in R_c/R , it was positive.

The behavior of dependencies (33), (37) and (38) is illustrated in Fig. 3.

B. Double-parabolic potential

More elaborate models may serve to illustrate the dependence of χ_0 and the slope of $\overline{\chi}(E/R)$ on some detail of the shape of the interplanar potential, both for positively and for negatively charged particles. In principle, the

⁵It represents a zero-barrier-thickness limit of the model considered in [14]. This may be regarded as a $Z \rightarrow \infty$ limit for positively charged particles in a crystal in orientation (110), although even for tungsten, the well shape is far from rectangular yet. For negatively charged particles in such a potential, $\overline{\chi}$ would equal zero.

integration can be done exactly for any piecewise-parabolic or piecewise-linear potential. For orientation (110), two parabolas can interpolate the planar potential within a period reasonably enough. For orientation (111), where the distances between the planes are not all equal but alternate, producing two inequivalent wells per period [see Fig. 5(b) below], that is necessary even in the crudest approximation. Let us thus consider the latter case first.

1. Orientation (111), positively charged particles

The continuous potential for positively charged particles in a silicon crystal in orientation (111) features two unequal potential wells per period [see Fig. 5(b) below]. For simplicity, let us neglect here the thermal smearing of the continuous potential near the planes, treating the potential as consisting of just two alternating parabolic wells of different widths d_S , d_L and depths V_S , $V_L > 0$. To facilitate correspondence with the cases of negatively charged particles, as well as orientation (110) considered below, it is expedient to write the continuous potential within a period in a symmetric form:

$$V(r) = \begin{cases} \mathcal{V}_1(r), & 0 \le r \le d_L/2, \\ \mathcal{V}_2(r), & d_L/2 \le r \le d - d_L/2, \\ \mathcal{V}_3(r), & d - d_L/2 \le r \le d, \end{cases}$$
(41)

where

$$\mathcal{V}_1(r) = V_L \left(\frac{2r}{d_L}\right)^2 \tag{42}$$

and

$$\mathcal{V}_3(r) = \mathcal{V}_1(d-r) = V_L \left(2\frac{d-r}{d_L}\right)^2 \tag{43}$$

are the halves of the two deep and broad wells, and

$$\mathcal{V}_2(r) = V_L - V_S + V_S \left(\frac{d-2r}{d_S}\right)^2,\tag{44}$$

with $d_L < d$, $V_S < V_L$, describes a minor midway well.

Under such conditions, we can apply formula (13). Evaluation of the corresponding partial integrals gives

$$\overline{\chi} = \frac{\pi}{2d} \left[d_L \theta_{cL} \left(1 - \frac{R_{cL}}{R} \right)^2 + d_S \theta_{cS} \left(1 - \frac{R_{cS}}{R} \right)^2 \right], \quad (45)$$

with

$$\theta_{cL} = \sqrt{\frac{2V_L}{E}}, \quad \theta_{cS} = \sqrt{\frac{2V_S}{E}}, \quad R_{cL} = \frac{Ed_L}{4V_L}, \quad R_{cS} = \frac{Ed_S}{4V_S}.$$

At that,

$$\chi_0 = \frac{\pi}{2} \left(\frac{d_L}{d} \theta_{cL} + \frac{d_S}{d} \theta_{cS} \right). \tag{46}$$

Therefore, the mean VR angle (45) in this case amounts to the average of critical angles for each of the subwells [cf. Eq. (33)], with weights proportional to the widths of the corresponding intervals. For the limiting value χ_0 that is rather obvious, in view of representation (15). Its validity through all orders in R_c/R owes to the similarity of shapes of the two unequal wells.

If condition $V_L/d_L = V_S/d_S$ is satisfied, wherewith $R_{cL} = R_{cS} = R_c$, then

$$\overline{\chi} = \chi_0 \left(1 - \frac{R_c}{R} \right)^2 \tag{47}$$

[with *R* dependence being similar to that in Eq. (33)]. Taking into account that for a real silicon crystal in (111) orientation $d_L/d_s = 3$, we find

$$\chi_0 = \frac{\pi \theta_{cL}}{8} (3 + 3^{-1/2}) = 1.4\theta_c.$$
(48)

At that, the product defined by Eq. (22) equals

$$K = \frac{3\pi^2}{2^9} (3 + 3^{-1/2})^2 = 0.74 < 1.$$
⁽⁴⁹⁾

It illustrates that inequality (23) may break down for a double well.

2. Orientation (111), negatively charged particles

For negatively charged particles in the same crystal orientation (111), the continuous potential is inverted upside down. Then, in effect, it contains just one well, which merely features a small bump in the middle of its bottom. For the present case, calculation by exact formula (12) leads to a rather bulky result, so, for simplicity, we will restrict ourselves to the NLO calculation.

The corresponding limiting angle (14) is computed as

$$\chi_0 = \sqrt{\frac{2}{E}} \frac{4}{d} \left[\int_0^{d_L/2} dr \sqrt{\mathcal{V}_1(r)} + \int_{d_L/2}^{d/2} dr \sqrt{\mathcal{V}_2(r)} \right]$$
$$= \sqrt{\frac{2V_L}{E}} + \frac{d_S}{d} \sqrt{\frac{2V_S}{E}} \left(\frac{V_L}{V_S} - 1\right) \operatorname{arth} \sqrt{\frac{V_S}{V_L}}.$$
 (50)

If $V_S < V_L/2$, arth in Eq. (50) may be expanded as $\operatorname{arth} \sqrt{\xi} \underset{\xi < 1/2}{\simeq} \sqrt{\xi}(1 + \xi/3)$, leaving

$$\chi_{0} \underset{V_{S} < V_{L}/2}{\simeq} \sqrt{\frac{2V_{L}}{E}} \left[1 + \frac{d_{S}}{d} \left(1 - \frac{2V_{S}}{3V_{L}} \right) \right].$$
(51)

Putting there values $d_S/d = 1/4$ and $V_S/V_L \approx 1/3$ corresponding to a real silicon crystal, one finds

$$\chi_0 = \sqrt{\frac{2V_L}{E}} \left(1 + \frac{7}{36} \right) \approx 1.2\theta_c.$$
 (52)

That is somewhat lower than for positively charged particles [cf. Eq. (48)], although the difference is not as significant as in the case of orientation (110) [cf. Eqs. (33) and (37) at $R/R_c \rightarrow \infty$].

The slope of the $\sqrt{E\chi}$ dependence on E/R can readily be evaluated, too. In total,

$$\sqrt{\frac{E}{2}}\overline{\chi} = \sqrt{V_L} \left[1 - \frac{Ed_L}{4V_L R} \left(1 + \ln \frac{4V_L R}{Ed} \right) \right] \\
+ \frac{d_S}{\sqrt{V_S}} \left(\frac{V_L - V_S}{d} - \frac{E}{2R} \right) \operatorname{arth} \sqrt{\frac{V_S}{V_L}} + \mathcal{O}\left(\frac{R_c^2}{R^2}\right).$$
(53)

Equation (53) is valid for any values of V_L , V_S , d_L , d_S , provided the coefficient at arth is positive:

$$V_L > V_S + \frac{Ed}{2R}.$$
(54)

Physically, that implies that the particle must have enough transverse energy to overpass the midway bump in the last interplanar interval of the bent crystal, in spite of the centrifugal tilt. It is also straightforward to check that in the formal limit $d_S \rightarrow 0$, the second line in (53) vanishes, and the result boils down to Eq. (37) for a sequence of purely parabolic barriers [relevant for orientation (110)]. In the opposite formal limit $d_L \rightarrow 0$ (a narrow major barrier), and $V_S \rightarrow 0$ (a wide but shallow bump), (53) goes over to the result (39) for the square well to the NLO in R_c/R [which was written there for positively charged particles in a high-Z crystal in orientation (110)].

3. Orientation (110), positively charged particles

The pure parabolic model for orientation (110) considered in Sec. IV A does not take into account the smoothness of the continuous potential in vicinities of atomic planes [cf. Fig. 5(a) below], which, as was shown in Sec. II, can give rise to a logarithmic modification of the linear E/R dependence. This shortcoming can be amended by adopting a double parabolic potential, among the pieces of which, in contrast to the situation of Secs. IV B 1 and IV B 2, one is convex upwards, while the other is convex downwards:

$$V(r) = \begin{cases} \mathcal{V}_1(r), & 0 \le r \le d_1/2, \\ \mathcal{V}_2(r), & d_1/2 \le r \le d - d_1/2, \\ \mathcal{V}_3(r), & d - d_1/2 \le r \le d. \end{cases}$$
(55)

Here

$$\mathcal{V}_2(r) = V_2 \left(\frac{d-2r}{d_2}\right)^2 \tag{56}$$

is the harmonic bottom of the potential well, with $d_2 < d$ and $V_2 < V_0$, whereas parts

$$\mathcal{V}_1(r) = V_2 + V_1 - V_1 \left(\frac{2r}{d_1}\right)^2,$$
 (57)

$$\mathcal{V}_3(r) = \mathcal{V}_1(d-r) = V_2 + V_1 - V_1 \left(2\frac{d-r}{d_1}\right)^2,$$
 (58)

with $d_1 = d - d_2 \ll d$ and $V_1 = V_0 - V_2 \ll V_0$, describe a parabolic smearing of the potential tops in vicinities of points r = 0 and r = d correspondingly. Thus defined function V(r) is continuous at $r = d_1/2$ and $r = d - d_1/2$. The requirement of its smoothness at those junctions imposes yet an additional condition $\mathcal{V}'_1(d_1/2) =$ $\mathcal{V}'_2(d_1/2)$, equivalent to

$$\frac{V_1}{d_1} = \frac{V_2}{d_2} = \frac{1}{4} F_{d_1/2}.$$
(59)

The adjustable parameters in this model are the total well depth V_0 and the shape parameter

$$\delta = \frac{d_1}{d} = \frac{V_1}{V_0}.\tag{60}$$

Potential (55) may be substituted to Eq. (12). As long as V_1 is small, in practice it will normally satisfy the inequality

$$V_{\text{eff1}}(d_1/2) > \max_{r > d_1/2} V_{\text{eff}}(r),$$
 (61)

wherewith the reflection point will belong to the domain of \mathcal{V}_2 rather than \mathcal{V}_1 [see Eq. (55)]. Condition (61) can be solved for *R* as

$$R < \frac{E}{4V_1}(\sqrt{d} + \sqrt{d_2})^2,$$
 (62)

where the right-hand side is much greater than

$$R_c = \frac{E}{F_{d_1/2}},\tag{63}$$

provided $d_1 \ll d_2$. Since condition (62) is usually met in practice, strictly speaking, in this model *R* cannot be regarded as asymptotically large. Therefore, the NLO formula does not strictly apply here, and to be rigorous, one has to return to Eq. (12).

In Appendix C it is shown that a satisfactory approximation for $\overline{\chi}$ under the present conditions is

Compared to Eq. (33), the main correction here stems from the overall factor $\sqrt{V_2} \approx \sqrt{V_0}(1 - \delta/2) < \sqrt{V_0}$. At that,

$$K = \frac{\pi^2}{8} (1 - \delta).$$
 (65)

It also appears that in spite of the smearing of the potential around the planes, the dependence of (64) on E/R under condition (62) does not contain a logarithmic factor, because the particle merely does not enter the smeared region at all.

The model (55) is already sufficiently detailed to be confronted with experimental data [5,9,24] available for silicon crystal in this orientation. Its fit used in the NLO equation (28) gives parameter values

$$V_0 = 20.2 \pm 0.4 \text{ eV}, \qquad \delta = 0.042 \pm 0.026.$$
 (66)

It is also close, with nearly the same but less tightly constrained parameters, to the calculation by exact formula (12) for model (55).

4. Orientation (110), negatively charged particles

To obtain from (55) the potential for negatively charged particles, there is no need to flip it and shift by half the period—it suffices just to replace δ by $1 - \delta$, which interchanges the small and large parameters: $d_1 \leftrightarrow d_2$, $V_1 \leftrightarrow V_2$. Since a negatively charged particle traverses all the three regions of piecewise-parabolic potential (55), the result of the exact calculation is more cumbersome. But the NLO calculation is simple. Evaluation by Eqs. (14) and (55)–(60) gives

$$\chi_0 = \sqrt{\frac{2V_2}{E}} \left[1 + \frac{d_1}{d} \left(\sqrt{\frac{V_1}{V_2}} + \sqrt{\frac{V_2}{V_1}} \right) \operatorname{arth} \sqrt{\frac{V_1}{V_2}} \right]$$
$$\simeq \theta_c (1 + \delta/2), \tag{67}$$

with $\theta_c = \sqrt{2(V_1 + V_2)/E}$ and $\delta = d_1/d \ll 1$, while evaluation of the slope can be done straightforwardly by Eq. (28):

$$\overline{\chi} = \chi_0 \left\{ 1 - \frac{R_c}{R} \left[1 + (1 - \delta) \ln \frac{R}{R_c} \right] \right\}.$$
 (68)

That explicates the δ -dependent correction to Eq. (37). Naturally, the increase of δ in turn increases χ_0 [in contrast to the case of positively charged particles—cf. Eq. (64)], whereas the slope diminishes, because the potential well broadens [see the commentary after Eq. (21)]. The expressions for $\overline{\chi}$ obtained in this subsection for double-parabolic model potentials exhibit surprisingly simple dependencies on various typical parameters. They can even provide rather accurate phenomenological predictions, which can be used for guidance in practice. But the meaning of such coincidences should not be overestimated.

V. $R \rightarrow R_c$ LIMIT

It may also be of interest to determine the behavior of $\overline{\chi}$ near the critical point $R = R_c$, although it can hardly be of high practical value, insofar as $\overline{\chi}$ there tends to zero. In the previous section we had seen that for parabolic potential models, $\overline{\chi}$ vanishes at the threshold quadratically:

$$\overline{\chi}/\theta_c \underset{R \to R}{\sim} (1 - R_c/R)^2.$$
(69)

But those models presume that the second derivative of the effective potential remains constant over the entire interplanar interval. In reality, the potential is smooth near the atomic planes. At $R \rightarrow R_c$ the potential well is tilted so strongly that the radicand of (12) is positive only in a small vicinity of point r_s , wherein $V'(r_s)$ is maximal, i.e., $V''(r_s) = 0$. To describe the effective potential under such a condition, one thus has to expand V(r) up to the third order in $r - r_s$:

$$V_{\rm eff}(r) = V_{\rm eff}(r_s) + (r - r_s) \left(V'(r_s) - \frac{E}{R} \right) + \frac{1}{6} (r - r_s)^3 V'''(r_s).$$

Here $V'(r_s) = F_{\text{max}} > 0$, and $V'''(r_s) < 0$. Therewith, integral (12) assumes the form⁶

$$\frac{d}{2}\overline{\chi}(E,R) = \sqrt{\frac{|V'''(r_s)|}{3E}} \int_{-2\sqrt{\lambda/3}}^{\sqrt{\lambda/3}} dr' \sqrt{2(\lambda/3)^{3/2} - \lambda r' + r'^3}$$
(70)

with $r' = r - r_s$ and $\lambda = \frac{6F_{\text{max}}}{|V'''(r_s)|} (1 - \frac{R_c}{R})$. Evaluating it, we get

$$\overline{\chi}_{R \to R_c} \frac{24}{5d} 2^{5/4} \left(\frac{E}{|V'''(r_s)|}\right)^{3/4} \left(\frac{1}{R_c} - \frac{1}{R}\right)^{5/4}.$$
 (71)

This relation is valid both for positively and for negatively charged particles.

Compared to (69), the decrease law in (71) is steeper, but the prefactor involves $|V'''(r_s)|^{-3/4} \sim u^{3/2}$, with *u* being the rms thermal displacement of atoms off the plane [see Eqs. (76) and (77) below], whereby ratio

⁶We will be specifically talking here about the single-well case (110). For the double-well case (111), critical points in both wells are reached almost simultaneously, so, their contributions should be added.

$$\frac{\overline{\chi}}{\mathcal{P}_c} \mathop{\sim}_{R \to R_c} \left(\frac{u}{d}\right)^{3/2} \left(1 - \frac{R_c}{R}\right)^{5/4} \tag{72}$$

is suppressed by a small factor $(u/d)^{3/2}$. Therefore, asymptotic law (71) holds only in a narrow vicinity of R_c , whereas at $R \sim 4R_c$ the behavior of $\overline{\chi}/\theta_c$ may be more similar to (69).

VI. USE OF REALISTIC POTENTIALS

Let us finally turn to a more realistic description of the mean VR angle, based on exact generic representations (12) and (13) for $\overline{\chi}$. Our knowledge of the interplanar potential, even though good, is in principle only approximate, and its uncertainty gives rise to some uncertainties in theoretical predictions. We will complete our study by assessing this sensitivity. That can be done best in comparison of predictions obtained with different potentials with experimental data. A comparison of experimental data with the potential deflection theory was formerly presented in [19] for positively charged particles. Later, there were also published detailed data for negatively charged particles reflecting on a crystal in orientation (111) [10]. Along with the phenomenological check of exact equations, it is important yet to assess the accuracy of NLO approximations derived in Sec. III.

A. World data. Intercepts and slopes

Experimental data on VR, obtained for various crystals and their orientations, for various incident particles and their energies, can be combined together by plotting $\sqrt{E\chi}$ vs E/R. Up-to-date data (see Figs. 6–8 below) do not exhibit a marked curvature, basically being compatible with linear dependencies. Thus, for those cases the logarithmic modification of the slope calculated in Sec. III and present in theoretical predictions for negatively charged particles in Figs. 8 and 9 is not revealed yet, because of the scatter between the points. Nonetheless, two numbers inferred from experimental data (the intercept and the slope of the linear dependence) for each particle charge sign and crystal orientation together can appreciably constrain the interplanar potential.

The tightest experimental constraint is for χ_0 , it corresponds to an accuracy of a few percent (standard deviation) —see Table I below. The slope $\sqrt{E} \frac{d(\sqrt{E\chi})}{d(E/R)}$ is constrained more loosely—only to within 5%–30%. Nonetheless, it can already rule out the crudest models, such as the pure parabolic potential for (110) orientation, containing only one parameter. For instance, for 400 GeV protons on Si (110) [5,9,24] from the linear regression to the experimental data one infers

$$K = 0.89 \pm 0.05, \tag{73}$$

which is more than 6 standard deviations below the corresponding pure parabolic potential model value (36).

It must be realized, though, that the experimentally covered range of curvatures extends somewhat beyond $1/4R_c$, wherewith the NLO approximation itself becomes insufficiently accurate, and the value of *K* determined in such a broad interval of 1/R appears to be underestimated due to sizable NNLO corrections. The use of Eq. (33) valid beyond the NLO improves the agreement, but does not make it perfect, anyway. A double parabolic potential model of Sec. IV B 3 has two adjustable parameters, by virtue of which it can sustain statistical comparison with VR experiments better.

B. Parametrizations for atomic potentials

Most valuable, of course, would be to compare the experimental data with predictions based on the best available potential. There are *ab initio* calculations thereof at a varying degree of sophistication, but the crystal structure is in principle more complicated than that of its constituent atoms. Therefore, a commonly adopted attitude for construction of crystal potentials is just to add potentials for isolated atoms,

$$V_{1a}(r) = \frac{Z_1 Z e^2}{r} g(r), \quad g(0) = 1, \quad g(r) \underset{r \to \infty}{\to} 0, \quad (74)$$

with Z_1 being the projectile charge in units of proton charge *e*, by placing them at the lattice sites, and neglecting interaction between the atoms, i.e., solid-state binding effects. When the number of covalently paired electrons is much smaller than the total electron number, their effect is expected to be relatively small. For silicon, there are four valence vs total 14 electrons (although half of the covalent bonds are extended along the considered low-index planes), so, the validity of this approximation may be not self-evident. Nonetheless, in this paper we confine our objective to comparing predictions from noninteractingatom potentials.

The potential of a thus obtained atomic plane has the form

$$V_{PS}(x) = n_s \int d^2 r_{\perp} V_{1a} \left(\sqrt{x^2 + r_{\perp}^2} \right)$$

= $2\pi n_s \int_{|x|}^{\infty} dr r V_{1a}(r),$ (75)

where n_s is the areal density of atoms in the plane. It is also necessary to average it over the thermal and zero-point fluctuations of the atom positions, convolving with a Gaussian distribution [25,26]:

$$V_P(x) = \int_{-\infty}^{\infty} dx' \frac{1}{\sqrt{2\pi}u} e^{-x^2/2u^2} V_{PS}(x-x'), \quad (76)$$

where the rms x projection of atom displacement at room temperature can be inferred directly from the dedicated experiments [27]:

$$u = 0.075 \text{ Å}$$
 (silicon, $T = 300 \text{ K}$). (77)

Finally, the potential of the entire crystal for orientation (110) is built from (75) and (76) as⁷

$$V(x) = \sum_{n=-\infty}^{\infty} V_P(x+nd), \qquad (78)$$

where d = 1.92 Å is the interplanar distance, whereas for orientation (111),

$$V(x) = \sum_{n=-\infty}^{\infty} V_P\{x + d_S(n+2\lfloor n/2\rfloor)\}, \qquad (79)$$

where $d_s = 0.78$ Å is the shorter interplanar distance (cf. Secs. IV B 1 and IV B 2), and $\lfloor n/2 \rfloor$ is the (lower) integer part of n/2.

One of the most commonly used parametrizations for the atomic potential screening function is that proposed long ago by Molière [28] as an analytic interpolation to the Thomas-Fermi approximation:

$$g(r) \approx \sum_{k=1}^{3} \alpha_k e^{-\beta_k r/a_{TF}}, \quad \alpha_k, \beta_k > 0, \quad \sum_{k=1}^{3} \alpha_k = 1.$$
 (80)

Accordingly, it depends on the ratio r/a_{TF} , where the Thomas-Fermi radius $a_{TF}(Z)$ equals

$$a_{TF} = 0.885 a_B Z^{-1/3} = 0.194 \text{ Å} \text{ for } Z = 14,$$
 (81)

with a_B the Bohr radius. But it is not devoid of shortcomings: the Poisson equation for a spherically symmetrical electron density $n_e(r)$,

$$g''(r) = \frac{4\pi}{Z} r n_e(r), \qquad \int d^3 n_e(r) = Z,$$
 (82)

implies that g''(r) along with the product $rn_e(r)$, where $n_e(r)$ is everywhere finite, must vanish⁸ at r = 0:

$$g''(0) = 0. (83)$$

In contrast, Molière parametrization gives $g''(0) = a_{TF}^{-2} \sum \alpha_k \beta_k^2 > 0$, since all $\alpha_k > 0$.

There is experimental evidence (see, e.g., [29]) that Molière parametrization predicts an excessive screening



FIG. 4. Screening function parametrizations for an isolated silicon atom. Black solid curve, Lobato-Van Dyck potential (90). Red solid, f_X -based Doyle-Turner potential (87). Red dotted, f_e -based Doyle-Turner potential (86). Black dashed, Molière potential (80) with modified screening radius (84). The axis ticks show characteristic atomic scales, such as the K-shell radius $a_K = a_B/Z$ and Thomas-Fermi radius (81), as well as the rms atom thermal displacement in a solid state (77).

radius. There were proposed various heuristic recipes for reducing it [26,30], for instance [31,32],

$$\tilde{a}_{TF} = 0.885 a_B (1 + Z^{2/3})^{-1/2} = 0.179 \text{ Å} \text{ for } Z = 14.$$
(84)

The most accurate approach for calculation of atomic structure is relativistic Hartree-Fock (HF). Two commonly used parametrizations of HF calculations of atomic structure were proposed by Doyle and Turner [33].⁹ One of them is for the electron scattering form factor

$$f_e(s) = \sum_{k=1}^4 a_k e^{-b_k s^2}, \qquad s = \frac{\sin \theta}{\lambda}, \tag{85}$$

with a_k , b_k given in Table 4 of [33], which is convenient for deriving the mean electrostatic potential:

$$\frac{Zg(r)}{r} = \frac{16\pi a_B}{r} \int_0^\infty dssf_e(s) \sin 4\pi sr$$
$$\approx 16\pi^{5/2} a_B \sum_{k=1}^4 \frac{a_k}{b_k^{3/2}} e^{-\frac{4\pi^2 r^2}{b_k}}.$$
(86)

It satisfies condition (83), but unfortunately, is plagued by a more severe intrinsic flaw: g(0) = 0 instead of 1 (see Fig. 4, dotted curve), and g'''(0) = 0 instead of value $\frac{4\pi}{Z}n_e(0)$ following from Poisson equation (82). This parametrization

⁷Albeit at evaluation of the VR angle the integration in (9), (10) and in the subsequent equations is carried out over a single period of the crystal, in (78) it is necessary to take a sufficiently large number of planes in order to ensure the symmetry of the potential with respect to any of its minima and maxima.

⁸For the static continuous potential of a single plane, according to Eq. (75), that implies $V_{PS}''(0) = 0$.

 $^{^{9}}$ In this, relatively old version of HF calculation, electron correlation effects were neglected. More modern, multiconfiguration HF, techniques [34,35] had assessed those effects on the mean electron density to be ~0.1%.

is nonetheless often used for channeling-related problems, including VR [1,10,36].

Another Doyle-Turner parametrization is for x-ray scattering factor:

$$f_X(s) = \frac{1}{s} \int_0^\infty dr r n_e(r) \sin 4\pi s r$$
$$\approx \sum_{k=1}^4 a_k e^{-b_k s^2} + c, \qquad (87)$$

where a_k , b_k , and $c = Z - \sum_{k=1}^4 a_k > 0$ are given in Table 3 of [33] or Table 6.1.1.4 of [37]. Constant $c \sim 1$ is arguably nonphysical, since it contradicts the correct asymptotic behavior $f_X(s) \underset{s \to \infty}{\simeq} \frac{|n'_e(0)|}{2^5 \pi^3 s^4}$, but parametrization (87) is intended to hold only for $s \leq 2$ Å⁻¹. In its original form, extended to arbitrary *s*,

$$g(r) = 1 - \frac{2}{\pi Z} \int_0^\infty \frac{ds}{s} f_X(s) \sin 4\pi sr$$

$$\approx \frac{1}{Z} \sum_k a_k \operatorname{erfc}\left(\frac{2\pi r}{\sqrt{b_k}}\right), \qquad (88)$$

where erfc is the complementary error function, it was used for description of VR in [13,19]. It obeys requirement (83), but predicts g(0) = 1 - c/Z < 1 (i.e., *c* out of *Z* electrons sitting exactly at the nucleus),¹⁰ and vanishing initial fourth derivative: $g^{(iv)}(0) = 0$, instead of $g^{(iv)}(0) = \frac{4\pi}{Z}n'_e(0)$ following from Poisson equation (82).

A completely self-consistent parametrization of HF data,

$$n_e(r) \approx 2\pi^4 a_B \sum_{k=1}^5 \frac{a_k}{b_k^{5/2}} e^{-\frac{2\pi r}{b_k^{1/2}}},$$
 (89)

was proposed in [38]. It consists of a sum of exponentials, like (80) (permitting some of parameters a_k to be negative), but is formulated for the electron density rather than the screening function. The latter derives as

$$g(r) \approx \frac{1}{Z} \sum_{k=1}^{5} N_k \left(1 + \frac{\mu_k r}{2} \right) e^{-\mu_k r},$$
 (90)

with

$$N_k = 2\pi^2 a_B \frac{a_k}{b_k}, \qquad \mu_k = \frac{2\pi}{\sqrt{b_k}}, \tag{91}$$

and the thermal-averaged potential of a single atomic plane reads



FIG. 5. Planar continuous potentials over one period for positively charged particles in a silicon crystal at room temperature, evaluated via Eqs. (74)–(79): (a) in orientation (110); (b) in orientation (111). Black solid curves, HF calculations [by any of Eqs. (86), (87) or (90)]. Blue dashed curves, Molière potential, Eqs. (80) and (81). Blue dot-dashed, Molière potential with modified screening radius (84).

$$V_{P}(x) \approx \frac{\pi n_{s} e^{2}}{2} \sum_{k=1}^{5} N_{k} \left\{ 2u \sqrt{\frac{2}{\pi}} e^{-x^{2}/2u^{2}} + e^{\mu_{k}^{2}u^{2}/2 + \mu_{k}x} \left(\frac{3}{\mu_{k}} - \mu_{k}u^{2} - x \right) \operatorname{erfc} \left[\frac{1}{\sqrt{2}} \left(\mu_{k}u + \frac{x}{u} \right) \right] + e^{\mu_{k}^{2}u^{2}/2 - \mu_{k}x} \left(\frac{3}{\mu_{k}} - \mu_{k}u^{2} + x \right) \operatorname{erfc} \left[\frac{1}{\sqrt{2}} \left(\mu_{k}u - \frac{x}{u} \right) \right] \right\}.$$
(92)

Although screening functions of HF potentials described above are markedly different at small r (see Fig. 4), the corresponding continuous planar potentials obtained after integration over longitudinal coordinates (75) and thermal averaging (76) are visually indistinguishable.¹¹ In Figs. 5(a) and 5(b) they correspond to the same solid curves. The Molière continuous potential, though, deviates from HF appreciably. The reason is that the Molière screening function deviates from HF at large r, whereas small-r

¹⁰Alternatively, one can let $f_X(s) = 0$ for s > 2 Å⁻¹. That fulfils condition g(0) = 1, but gives rise to an oscillatory component in g(r) at r > 0.

¹¹The amplitude Debye-Waller factor $e^{-(4\pi s u)^2/2}$ with *u* given by Eq. (77) and s = 2 Å⁻¹ equals 0.17, which is small enough to completely suppress already small values of the form factor in that region.



FIG. 6. Dependence of the mean VR angle for positively charged particles with energy E = 400 GeV in silicon crystal in orientation (110) on the crystal curvature. Points, measurements in different experiments: blue, [24]; green, [5]; red, [9]. Curves: blue dashed, Molière potential [with ordinary screening radius (81)] at room temperature [Eq. (77)]; black solid, HF potential (92); black dot-dashed, NLO prediction for HF potential, Eqs. (28) and (29); black dotted, static NLO prediction for HF potential, Eq. (25).



FIG. 7. Dependence of the mean VR angle for positively charged particles with energy E = 400 GeV in silicon crystal in orientation (111) on the crystal curvature. Points: blue, [5]; green, [6]; red, [9]. Curves: the same as in Fig. 6.

variations are less important, being smeared out by averaging procedures, anyway. However, the Molière potential with modified screening radius (84), even though fortuitously, is very close to HF, as well. In this sense, it can be regarded as competitive.

C. Comparison with experiments

The theoretical predictions for the mean VR angle computed by Eq. (12) or (13) with Molière and HF potentials, as well as NLO predictions for HF potential computed by Eqs. (28) and (29), are compared with the experimental data in Figs. 6–9. Given that roomtemperature planar potentials for all types of HF screening



FIG. 8. Energy dependence of the mean VR angle for negatively charged particles in silicon crystal in orientation (111) at R = 15 cm. Points, experimental data [10]. Curves: the same as in Fig. 6. A break in the curves around E = 18 GeV occurs because the minor potential bump rises above the major barrier due to the large tilt, making the potential double-well instead of single-well. At that, one has to switch from Eq. (12) to Eq. (13).



FIG. 9. E/R dependence of the mean VR angle for negatively charged particles in silicon crystal in orientation (110). Points: blue, measurement [7] for E = 150 GeV and R = 22.79 m; green, measurement [11] for E = 120 GeV and R = 2.71 m. Curves: the same as in Fig. 6.

functions are very close (Fig. 5), it is natural that their predictions for the mean VR angle are indistinguishable in the figures. It can be seen from the plots that the HF potential predictions are generally the most accurate, whereas the original Molière potential, as was previously pointed out in [19], tends to give excessive predictions. But its relative deviation is twice smaller than that for the potential well depths in Fig. 5, which is natural in view of the square root dependence on the potential in Eqs. (12), (13). So, the sensitivity of $\overline{\chi}$ to the interplanar potential shape can be regarded as moderate. The predictions of the Molière potential with modified screening radius (84), in fact, virtually fall on top of the HF curves, too.

TABLE I. Mean values of $\langle \sqrt{\max V - V(r)} \rangle_r$ (in eV^{1/2}) as determined from experimental data on $\frac{1}{2} \sqrt{\frac{E}{2}} \chi_0$ [5,6,9,10,24], in comparison with predictions based on model potentials. Molière potential corresponds to the screening radius evaluated by Eq. (81). Molière with modified $a_{\rm TF}$ is evaluated via Eq. (84).

	(110) pos. ch.	(111) pos. ch.	(111) neg. ch
Experiments	3.39 ± 0.04	3.0 ± 0.1	2.9 ± 0.1
Molière	3.77	3.52	2.86
Molière, modified $a_{\rm TF}$	3.68	3.43	2.74
Doyle-Turner, f_e -based	3.6437	3.387	2.734
Doyle-Turner, f_X -based	3.6439	3.389	2.729
Lobato-Van Dyck	3.6445	3.389	2.729

The curve slopes depend on the atomic potential weakly, so, the main differences in their values stem from the differences in χ_0 . The latter, according to Eqs. (15)–(16), boils down to $\langle \sqrt{\max V - V(r)} \rangle_r$. The values of $\langle \sqrt{\max V - V(r)} \rangle_r$ inferred from a linear fit to the experimental data for $\frac{1}{2}\sqrt{\frac{E}{2}}\chi_0$, as well as from theoretical predictions, are listed in Table I. This table allows one to assess subtle differences between the predictions of different potentials.

It should be cautioned that the pure continuous potential deflection theory is valid under condition

$$R \ll R_{\rm mult}(E),\tag{93}$$

where the parameter in the rhs, quantifying the onset of incoherent multiple scattering effects,¹² may be evaluated by the engineering formula (64) of [17]:

$$R_{\rm mult} = \left(\frac{E}{18 \text{ GeV}}\right)^{5/4} \text{ [m]}.$$
 (95)

At $R^{-1} \lesssim R_{\text{mult}}^{-1}$, the experimental points in Figs. 6 and 7 subside below the theoretical prediction. Quantitative explanation of this effect is challenging for the analytic theory.

The logarithmically modified NLO approximation developed in Sec. III C (blue dot-dashed curves in Figs. 6–9) proves to work nicely for negatively charged particles (Figs. 8 and 9). For positively charged particles, its

$$\sqrt{\Delta E_{\perp}/E} \gg \sigma_{\rm am}(\Delta z),$$
 (94)

application leads to somewhat worse, slightly *excessive* predictions (compared with the exact result) in the intermediate region. This resembles the situation with a square well, rather than parabolic potential (see the end of Sec. IVA), although visually interplanar potentials in Fig. 5 look close to parabolic. That occurs because, as was mentioned in Sec. III C, the thermally smeared potential around the atomic planes is not described by a reverted parabola at a long extent, and at intermediate R_c/R , radial reflection points belong to a nonparabolic region.

If instead one employs the NLO formula for the static potential [Eq. (25)], which is displayed in Figs. 6 and 7 by dotted curves, it proves to be closer to the exact result at moderate R_c/R , while being somewhat worse at $R_c/R \rightarrow 0$, which is not surprising since this approximation is not truly asymptotic. But physically, at very small R_c/R , as was mentioned above, the pure potential description of deflection is invalid, anyway. Therefore, in practice, the use of the static-potential NLO approximation may have certain advantages.

Finally, it attracts attention that experimental data for negatively charged particles, at least for orientation (111) (see Fig. 8), overshoot the theoretical curves, not being reproduced by any of the most commonly used potentials sufficiently well (as was mentioned above, the discrepancies are primarily in χ_0). Furthermore, the prediction by Molière potential appears to be closer to those data than HF, although in other cases it was vice versa. In this regard, one can consider two basic possibilities.

The first one is to recall that the experimental procedure for determination of $\overline{\chi}$ consists in fitting the measured angular distribution of transmitted particles by a superposition of Gaussian-related functions, each of which is associated with a certain particle fraction (channeled, dechanneled or VR). But for negatively charged VR particles, the angular distribution has a rather long "tail" towards the crystal bending due to "orbiting" of particles at the tops of broad interplanar potential maxima [15]. Such particles can be misidentified as not belonging to the VR fraction (instead being included to the quickly dechanneled and multiply scattered fraction), and their subtraction increases the mean VR angle.¹³

Second, it should be borne in mind that even though the noninteracting-atom approximation is rather good for thirdrow chemical elements (much better than for second-row elements [39,40]), covalent binding effects can nonetheless somewhat alter the interplanar potential [39,41,42], and hence have some impact on χ_0 . Recalling also (see Fig. 4) that the observed difference of the continuous planar

¹²That is, breakdown of condition

where the lhs is the typical angle of atomic plane crossing by a VR particle near the radial reflection point, and the rhs is the rms incoherent multiple scattering angle acquired in the intrinsic VR region of the length Δz defined by Eq. (7). Violation of condition (94) will lead to impossibility for the particle to pass the entire sequence of potential wells, and hence to a decrease of the reflection angle.

¹³It may be mentioned yet that experiment [10] was performed with a rather thin crystal ($L = 60 \ \mu m$), whereas herein we presume validity of the thick-crystal limit. Nonetheless, condition (8) for it is fulfilled. Besides that, boundary effects are not expected to be strictly positive, and thus cannot explain the stable excess of the data over the theory predictions.

Molière potential from planar HF potential arose due to a difference between their atomic screening functions at large r (~1 Å), where the applicability of the noninteractingatom approximation generally breaks down, it is not excluded that real deformations of the valence electron density may give rise to observable differences in continuous potentials, as well.

If one considers a possibility that the good agreement for χ_0 for positively charged particles could be partly fortuitous, and looks for a modification of the interplanar potential such that the value of χ_0 is unaffected for positively charged particles, but increases for negatively charged ones, qualitatively, it may be instructive to refer to the double-parabolic potential model of Sec. IV B 3 [for simplicity, for the case of orientation (110)]. There, χ_0 for positively charged particles was expressed by an explicit function $\chi_0 \propto \sqrt{V_0(1-\delta)}$ of the potential depth V_0 and shape parameter δ [see Eq. (64)]. If the latter is increased so that product $V_0(1-\delta)$ remains constant, for positively charged particles χ_0 will not change, whereas for negatively charged ones, it will increase by factor $1 + \delta$ [see Eq. (67)]. Physically, the increase of δ corresponds to an increase of the potential curvature midway the planes, which, from the viewpoint of the Poisson equation does not contradict to formation of covalent bonds in that region. But to achieve quantitative agreement with the data, one needs sizable $\delta \sim 0.1$, whereas the fitted value (66) is significantly lower. Proper investigation of this issue is beyond the scope of the present paper.

VII. SUMMARY AND OUTLOOK

The developed approach for evaluation of the mean volume reflection angle solves the problem of summation over the crystal periods exactly. Apart from the apparent convenience for making numerical predictions, it also permits a number of qualitative inferences. In particular, it reveals a duality between VR and channeled particles, in the sense that only under-barrier regions of the effective potential contribute to the mean VR angle. The limiting (at $4R_c/R \ll 1$) value of the latter proves to be related with a net critical channeling angle for a straight crystal (its local generalization averaged over the interplanar interval).

It is also noteworthy that in practice, for description of *E* and *R* dependencies of $\overline{\chi}$, it may be sufficient to use NLO expansion in the small ratio R_c/R (Sec. III). That demands the knowledge of only a few empirical constants, calculable numerically based on a realistic interplanar potential for a straight crystal. NLO formulas for orientation (110) and for parabolic interplanar potential were formerly implemented in the Monte Carlo code FLUKA [43]; they can be improved based on the present development.

Cases of medium $R/4R_c$ and $R \rightarrow R_c$ were also studied. At $R \leq 4R_c$, some guidance can be provided by parabolic potential models of Sec. IV, offering simple closed-form expressions for $\overline{\chi}$. The most accurate predictions, though, are obtained with HF potentials.

The comparison between the theory and results of experiment [10] on VR of negatively charged particles and crystal orientation (111) displays yet some discrepancy (Sec. VIC), the interpretation of which requires further investigation. More data on VR of negatively charged particles for all crystal orientations are desirable.

It is worth recapitulating that in the present paper, VR was everywhere treated as a purely elastic deflection process. In reality, it is accompanied by weakly inelastic and quasielastic scattering processes, which need to be understood, as well. In particular, they give rise to a non-negligible volume capture probability, due to which the VR efficiency even at high energy can amount to less than 90%.

Another kind of inelastic processes is emission of electromagnetic radiation, which can be intense for ultrarelativistic electrons and positrons passing through crystals [8,11,44]. For radiation at VR, the deviation of the spectrum from the kinematically formed coherent bremsstrahlung in a bent crystal (generated away from the intrinsic VR region) is concentrated in the low- ω region [45]. The infrared limit $\omega \to 0$ itself is rather trivial, corresponding to factorization of the radiation and scattering probabilities [45]. Less trivial is the slope of the radiation spectrum at the origin. For the latter quantity, there was derived a generic expression depending on the detail of the particle trajectory inside the target [46]. To describe that behavior, however, one needs to go beyond the present theory, which deals only with the final deflection angle.

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APPENDIX A: DERIVATION OF FORMULA (10)

In this Appendix we derive formula (10) central for the present paper. If one is interested in the mean VR angle alone, rather than in the detail of the angular distribution, it can be evaluated by interchanging the order of integrations in the double integral arising when Eq. (5) is inserted into Eq. (4). The dependence of the integrand on E_{\perp} is very simple and should thus be manageable exactly.

To interchange the order of integrations, one must first take into account that the lower limit $r_{\min}(E_{\perp})$ of r integrations is E_{\perp} dependent. Since $r_{\min}(E_{\perp})$ by definition is a maximal r such that $V_{\text{eff}}(r) = E_{\perp}$, condition $r > r_{\min}(E_{\perp})$ equivalently expresses as an r-dependent lower bound for E_{\perp} :



FIG. 10. Red solid curve, lower boundary of the energetically allowed domain for VR in the $\{r, E_{\perp}\}$ plane. Semi-infinite row restricted by the red curve and the horizontal dashed lines—initial integration region for the mean VR angle. Semi-infinite column restricted by the red curve and the vertical dashed lines—the transformed integration region. Arrows show translations of double-full-period cells, not changing the integrand.

$$E_{\perp} > \min E_{\perp}(r) = \max_{r' \ge r} V_{\text{eff}}(r'). \tag{A1}$$

The absolute minimum of r is subsequently inferred by noting that the dependence (A1) is monotonic, whence the minimal r corresponds to the maximal E_{\perp} , i.e., to const + ΔE_{\perp} . Without the loss of generality, the origin of coordinate r can be chosen so that

$$r_{\min}(\operatorname{const} + \Delta E_{\perp}) = 0.$$

Therewith,

$$\sqrt{\frac{E}{2}}\overline{\chi} = \lim_{r_0 \to \infty} \left\{ 2\sqrt{\frac{Er_0}{R}} - \frac{1}{d} \int_0^{r_0} dr \int_{\max_{r' \ge r}}^{\operatorname{const} + \Delta E_{\perp}} \frac{dE_{\perp}}{\sqrt{E_{\perp} - V_{\text{eff}}(r)}} \right\}.$$
(A2)

The corresponding integration domain in the $\{r, E_{\perp}\}$ plane is shown by a horizontal band in Fig. 10.

We are now in a position to make use of the periodicity of V(r). The integrand of the double integral in (A2) is periodic both in *r* and E_{\perp} at constant $E_{\perp} + \frac{E}{R}r$. If we split the integral with respect to *r* into a sum of integrals over full periods,

$$\int_0^{r_0} dr = \int_0^d dr + \int_d^{2d} dr + \dots + \int_{\lfloor r_0/d \rfloor}^{r_0} dr,$$

each of the partial integrals can be presented as an integral over the same period [0, d], in whose integrand there is yet a compensating shift in the linear component of $V_{\text{eff}}(r)$. But those shifts can as well be reexpressed as shifts in E_{\perp} , whereby we obtain a sum of integrals over E_{\perp} :

$$\begin{split} & \left| \frac{E}{2} \overline{\chi} = \lim_{r_0 \to \infty} \left\{ 2\sqrt{\frac{Er_0}{R}} \\ & -\frac{1}{d} \int_0^d dr \sum_{k=0}^{r_0/d} \int_{\max_{r' \ge r} V_{\text{eff}}(r')}^{\text{const} + \Delta E_\perp} \frac{dE_\perp}{\sqrt{E_\perp + k\Delta E_\perp - V_{\text{eff}}(r)}} \right\} \end{split}$$

One observes that they seamlessly combine into a single integral with respect to E_{\perp} with the upper limit $\Delta E_{\perp} r_0/d = E r_0/R$:

$$\sqrt{\frac{E}{2}}\overline{\varkappa} = \lim_{r_0 \to \infty} \left\{ 2\sqrt{\frac{Er_0}{R}} -\frac{1}{d} \int_0^d dr \int_{\substack{n \ge V_{\text{eff}}(r')\\ r' \ge r}}^{\Delta E_\perp r_0/d} \frac{dE_\perp}{\sqrt{E_\perp - V_{\text{eff}}(r)}} \right\}. \quad (A3)$$

Graphically this transformation is illustrated in Fig. 10. The E_{\perp} integration then performs exactly in a trivial manner, and the limit $r_0 \rightarrow \infty$ is evaluated to give Eq. (10).

APPENDIX B: DERIVATION OF FORMULA (28)

In this Appendix we complete the derivation of the logarithmic modification of the generic NLO formula, which was reduced to two integrals in Eq. (27), involving an auxiliary "intermediate-scale" parameter r_i . It is expedient first to isolate there the LO contribution (14), complementing the integral $\int_{r_i}^d dr \sqrt{\max V - V(r)}$ to an integral over the full period:

$$\begin{split} \int_{r_i}^d dr \sqrt{\max V - V(r)} &\simeq \int_0^d dr \sqrt{\max V - V(r)} \\ &- \sqrt{\frac{|V''(0)|}{2}} \frac{r_i^2}{2}. \end{split}$$

Its last term combines with the first term in the right-hand side of Eq. (27) to give

$$\begin{aligned} \Re \mathbf{e} & \int_{0}^{r_{i}} dr \sqrt{r^{2} + \frac{2Ed}{RV''(0)}} - \frac{r_{i}^{2}}{2} \\ & \underset{r_{i}^{2} \gg \frac{2Ed}{R|V''(0)|}}{\simeq} \frac{Ed}{2RV''(0)} \left[1 + \ln \frac{2R|V''(0)|}{Ed} + 2\ln r_{i} \right] \end{aligned}$$

(terms quadratic in the auxiliary parameter r_i have canceled). Therewith, Eq. (27) becomes

$$\overline{\chi} = \chi_0 - \frac{1}{R} \sqrt{\frac{E}{|V''(0)|}} \left[1 + \ln \frac{2R|V''(0)|}{Ed} + 2\ln r_i - \frac{\sqrt{2|V''(0)|}}{d} \int_{r_i}^d dr \frac{r-d}{\sqrt{\max V - V(r)}} \right] + \mathcal{O}\left(\frac{E^2}{R^2}\right).$$
(B1)

Cancellation of r_i may be accomplished in two ways. One option is to combine the last two terms in the brackets, using the symmetry of the potential with respect to the interplanar interval midpoint r = d/2, i.e., V(d - r) = V(r):

$$\frac{1}{d} \int_{r_i}^{d} dr \frac{r-d}{\sqrt{\max V - V(r)}} \equiv -\int_{r_i}^{d/2} \frac{dr}{\sqrt{\max V - V(r)}}$$
$$= \int_{r_i}^{d/2} d\ln \frac{d}{2r} \frac{r}{\sqrt{\max V - V(r)}}$$
$$= \frac{1}{\sqrt{|V''(0)|/2}} \ln \frac{2r_i}{d} - \int_{r_i}^{d/2} dr \ln \frac{d}{2r} \frac{d}{dr} \frac{r}{\sqrt{\max V - V(r)}},$$

where the latter integral already converges at $r_* \rightarrow 0$. That leads to the result

$$\overline{\chi} = \chi_0 - \frac{1}{R} \sqrt{\frac{E}{|V''(0)|}} \left(1 + \ln \frac{R|V''(0)|d}{2E} \right) \\ - \frac{\sqrt{2E}}{R} \int_0^{d/2} dr \ln \frac{d}{2r} \frac{d}{dr} \frac{r}{\sqrt{\max V - V(r)}} + \mathcal{O}\left(\frac{d^2}{R^2 \theta_c^3}\right).$$
(B2)

Alternatively, one can choose such a $r_i = r_*$ that in (B1) all the terms in the brackets except the integral cancel:

$$1 + \ln \frac{2R|V''(0)|}{Ed} + 2\ln r_* = 0.$$

That leads to expression (29) for r_* and to representation (28) for $\overline{\chi}$.

APPENDIX C: DERIVATION OF FORMULA (64)

Here we derive an approximation for the mean VR angle in a single-well potential described by two joint parabolas, Eq. (55), suitable under conditions (62) and $d_1 \ll d_2$. Our starting point is Eq. (12).

When the centrifugal potential $-\frac{Er}{R}$ is added to the crystal potential (58), under condition $R \gg R_c$, the location of the maximum of the tilted effective potential shifts from *d* only slightly: $r_m = d - \frac{Ed_1^2}{8V_1R} = d - \frac{d_1}{2}\frac{R_c}{R}$. The effective potential value in this maximum equals $V_{\text{eff}}(r_m) = \mathcal{V}_3(r_m) - \frac{Er_m}{R}$. Exact evaluation of the integral (12) for potential (55) then gives

$$\begin{split} \sqrt{\frac{E}{2}} \frac{d}{2} \overline{\chi} &= \int_{d_1/2}^{d-d_1/2} dr \Re \mathbf{e} \sqrt{\mathcal{V}_3(r_m) - \mathcal{V}_2(r) + \frac{E(r - r_m)}{R}} + \int_{d-d_1/2}^{r_m} dr \sqrt{\mathcal{V}_3(r_m) - \mathcal{V}_3(r) + \frac{E(r - r_m)}{R}} \\ &= \Re \mathbf{e} \int_{d_1/2}^{d-d_1/2} dr \left[V_1 \left(1 - \frac{Ed_1}{4RV_1} \right)^2 + V_2 \left(1 - \frac{Ed_2}{4RV_2} \right)^2 - V_2 \left(\frac{d-2r}{d_2} + \frac{Ed_2}{4RV_2} \right)^2 \right]^{1/2} + \int_{d-d_1/2}^{r_m} dr \sqrt{V_1} 2 \frac{r_m - r}{d_1}, \end{split}$$
(C1)

or, evaluating the latter simple integrals,

$$\sqrt{\frac{E}{2}} \frac{d}{2} \overline{\chi} = \frac{d_1 \sqrt{V_1}}{4} \left(1 - \frac{Ed_1}{4RV_1} \right)^2 + \frac{d_2 \sqrt{V_1}}{4} \left(1 - \frac{Ed_2}{4RV_2} \right) \left(1 - \frac{Ed_1}{4RV_1} \right)
+ d_2 \frac{V_1 \left(1 - \frac{Ed_1}{4RV_1} \right)^2 + V_2 \left(1 - \frac{Ed_2}{4RV_2} \right)^2}{4\sqrt{V_2}} \left[\pi - \arctan\left(\frac{1 - \frac{Ed_1}{4RV_1}}{1 - \frac{Ed_2}{4RV_2}} \sqrt{\frac{V_1}{V_2}} \right) \right].$$
(C2)

Invoking condition (59), wherewith $\frac{Ed_1}{4V_1} = \frac{Ed_2}{4V_2} = R_c$, expression (C2) simplifies to

$$\overline{\chi} = \sqrt{\frac{V_2}{2E}} \left(\pi + \sqrt{\frac{V_1}{V_2}} - \arctan\sqrt{\frac{V_1}{V_2}} \right) \left(1 - \frac{R_c}{R} \right)^2.$$
(C3)

Notably, all the E/R dependence here is given by the same factor $(1 - \frac{R_c}{R})^2$ as for the purely parabolic well, cf. Eq. (33).

In the limit $R/R_c \rightarrow \infty$, however, expression (C3) does not exactly tend to χ_0 , because it was derived presuming condition (62), where the right-hand side is large but finite. Its precise limiting value can be obtained by returning to formula (14):

$$\chi_{0} = \sqrt{\frac{2}{E}} \frac{4}{d} \left[\int_{0}^{d_{1}/2} dr \sqrt{V_{1} + V_{2} - \mathcal{V}_{1}(r)} + \int_{d_{1}/2}^{d/2} dr \sqrt{V_{1} + V_{2} - \mathcal{V}_{2}(r)} \right]$$
$$= \sqrt{\frac{2V_{1}}{E}} + \frac{d_{2}}{d} \sqrt{\frac{2}{EV_{2}}} (V_{1} + V_{2}) \operatorname{arccot} \sqrt{\frac{V_{1}}{V_{2}}}, \quad (C4)$$

or, with the use of condition (59),

$$\chi_0 = \sqrt{\frac{2V_2}{E}} \left(\frac{\pi}{2} + \sqrt{\frac{V_1}{V_2}} - \arctan\sqrt{\frac{V_1}{V_2}} \right). \quad (C5)$$

But as long as $V_1/V_2 \lesssim 0.1$, the difference $\sqrt{\frac{V_1}{V_2}} - \arctan \sqrt{\frac{V_1}{V_2}} \approx \frac{1}{3} (\frac{V_1}{V_2})^{3/2} \lesssim 0.01$ with an acceptable accuracy may be neglected both in (C3) and (C5), leaving

$$\overline{\chi} \approx \frac{\pi}{2} \sqrt{\frac{2V_2}{E}} \left(1 - \frac{R_c}{R}\right)^2.$$
(C6)

That approximation can already be used for arbitrarily large R.

- W. Scandale and A. M. Taratin, Channeling and volume reflection of high-energy charged particles in short bent crystals. Crystal assisted collimation of the accelerator beam halo, Phys. Rep. 815, 1 (2019).
- [2] Yu. M. Ivanov *et al.*, Volume reflection of 1-GeV protons by a bent silicon crystal, JETP Lett. **84**, 372 (2006).
- [3] Yu. M. Ivanov *et al.*, Volume Reflection of a Proton Beam in a Bent Crystal, Phys. Rev. Lett. **97**, 144801 (2006).
- [4] W. Scandale *et al.*, High-Efficiency Volume Reflection of an Ultrarelativistic Proton Beam with a Bent Silicon Crystal, Phys. Rev. Lett. **98**, 154801 (2007).
- [5] W. Scandale *et al.*, Deflection of 400 GeV/c proton beam with bent silicon crystals at the CERN Super Proton Synchrotron, Phys. Rev. ST Accel. Beams 11, 063501 (2008).
- [6] W. Scandale *et al.*, Double volume reflection of a proton beam by a sequence of two bent crystals, Phys. Lett. B 658, 109 (2008).
- [7] W. Scandale *et al.*, Observation of channeling and volume reflection in bent crystals for high-energy negative particles, Phys. Lett. B 681, 233 (2009).

- [8] S. Hasan *et al.*, Volume reflection observations in bent crystals with 13 GeV/c particles, Nucl. Instrum. Methods Phys. Res., Sect. B 269, 612 (2011).
- [9] R. Rossi, G. Cavoto, D. Mirarchi, S. Redaelli, and W. Scandale, Measurements of coherent interactions of 400 GeV protons in silicon bent crystals, Nucl. Instrum. Methods Phys. Res., Sect. B 355, 369 (2015).
- [10] T. N. Wistisen *et al.*, Channeling, volume reflection, and volume capture study of electrons in a bent silicon crystal, Phys. Rev. Accel. Beams **19**, 071001 (2016).
- [11] L. Bandiera *et al.*, On the radiation accompanying volume reflection, Nucl. Instrum. Methods Phys. Res., Sect. B **309**, 135 (2013).
- [12] A. M. Taratin and S. A. Vorobiev, Deflection of highenergy charged particles in quasi-channeling states in bent crystals, Nucl. Instrum. Methods Phys. Res., Sect. B 26, 512 (1987).
- [13] V. A. Maisheev, Volume reflection of ultrarelativistic particles in single crystals, Phys. Rev. ST Accel. Beams 10, 084701 (2007).
- [14] G. V. Kovalev, Volume reflection and volume refraction of relativistic particles in a uniformly bent crystal, JETP Lett.
 87, 87 (2008).
- [15] M. V. Bondarenco, Model solution for volume reflection of relativistic particles in a bent crystal, Phys. Rev. A 82, 042902 (2010); Comments on theory of volume reflection and radiation in bent crystals, Il Nuovo Cimento C 34, 381 (2011).
- [16] M. V. Bondarenco, A relation between the nuclear scattering probability in a bent crystal and the mean volume reflection angle, Phys. Lett. A **376**, 875 (2012).
- [17] M. V. Bondarenco, Nuclear interactions at volume reflection: Perturbative treatment, Phys. Rev. ST Accel. Beams 15, 032802 (2012).
- [18] N. F. Shul'ga, V. I. Truten, V. V. Boyko, and A. S. Esaulov, Scattering of high-energy particles by field of the bent crystal atomic planes, Phys. Lett. A 376, 2617 (2012).
- [19] S. Bellucci, Yu. A. Chesnokov, V. A. Maisheev, and I. A. Yazynin, Volume reflection and volume capture of ultrarelativistic particles in bent single crystals, Phys. Rev. ST Accel. Beams 18, 114701 (2015).
- [20] V. V. Kaplin and S. A. Vorobiev, On the electromagnetic radiation of channeled particles in a curved crystal, Phys. Lett. A 67, 135 (1978).
- M. V. Bondarenco, at Channeling-2018: https://agenda.infn .it/event/14872/contributions/26997/attachments/19334/ 21900/16.00_ch2018_Bondarenco.pdf; M. V. Bondarenco, Dr.Sci. thesis, Kharkov Inst. Phys. Techn., 2019.
- [22] I. S. Gradshteyn and I. M. Ryzhik, *Tables of Integrals*, *Series and Products*, 5th ed. (Academic Press, San Diego, 1980); T. M. Apostol, *Introduction to Analytic Number Theory* (Springer, New York, 1976).
- [23] M. B. H. Breese and V. M. Biryukov, Enhanced beam deflection in bent crystals using multiple volume reflection, Nucl. Instrum. Methods Phys. Res., Sect. B 263, 395 (2007).
- [24] W. Scandale *et al.*, Volume Reflection Dependence of 400 GeV/c Protons on the Bent Crystal Curvature, Phys. Rev. Lett. **101**, 234801 (2008).
- [25] B. R. Appleton, C. Erginsoy, and W. M. Gibson, Channeling effects in the energy loss of 3-11-MeV protons in

silicon and germanium single crystals, Phys. Rev. **161**, 330 (1967).

- [26] D. S. Gemmell, Channeling and related effects in the motion of charged particles through crystals, Rev. Mod. Phys. 46, 129 (1974).
- [27] B. W. Batterman and D. R. Chipman, Vibrational amplitudes in germanium and silicon, Phys. Rev. 127, 690 (1962); B. Zhang, J. Yang, L. Jin, C. Ye, J. Bashir, N. M. Butt, M. Siddique, M. Arshed, and Q. H. Khan, Temperature factor of silicon by powder neutron diffraction, Acta Crystallogr. Sect. A 46, 435 (1990).
- [28] G. Molière, Theorie der Streuung schneller geladener Teilchen. I. Einzelstreuung am abgeschirmten Coulomb-Feld, Z. Naturforsch. 2a, 133 (1947).
- [29] S. Schwabe and R. Stolle, Multiple scattering of lithium ions with energies from 10 to 50 keV in various target materials, Phys. Status Solidi B 47, 111 (1971).
- [30] J. F. Ziegler, J. P. Biersack, and M. D. Ziegler, SRIM—The stopping and range of ions in matter, SRIM Co., 2009, ISBN 978-0-9654207-1-6.
- [31] N. Bohr, The penetration of atomic particles through matter, Mat. Fys. Medd. K. Dan. Vidensk. Selsk 18, 1 (1948).
- [32] J. Lindhard, V. Nielsen, and M. Scharff, Approximation method in classical scattering by screened Coulomb fields, Mat. Fys. Medd. K. Dan. Vidensk. Selsk 38, 1 (1968).
- [33] P. A. Doyle and P. S. Turner, Relativistic Hartree-Fock X-ray and electron scattering factors, Acta Crystallogr. A 24, 390 (1968).
- [34] D. Rez, P. Rez, and I. Grant, Dirac-Fock calculations of X-ray scattering factors and contributions to the mean inner potential for electron scattering, Acta Crystallogr. Sect. A 50, 481 (1994).
- [35] H. Meyer, T. Müller, and A. Schweig, Accurate elastic scattering factors for lithium to argon based on correlated wavefunctions, Acta Crystallogr. Sect. A 51, 171 (1995).

- [36] A. I. Sytov *et al.*, Steering of Sub-GeV electrons by ultrashort Si and Ge bent crystals, Eur. Phys. J. C 77, 901 (2017).
- [37] International Tables for Crystallography, Vol. C: Mathematical, physical and chemical tables, 3rd ed., edited by E. Prince (Kluwer Acadademic Publishers, Dordrecht, 2004).
- [38] I. Lobato and D. Van Dyck, An accurate parameterization for scattering factors, electron densities and electrostatic potentials for neutral atoms that obey all physical constraints, Acta Crystallogr. Sect. A **70**, 636 (2014).
- [39] E. Nishibori, E. Sunaoshi, A. Yoshida, S. Aoyagi, K. Kato, M. Takata, and M. Sakata, Accurate structure factors and experimental charge densities from synchrotron X-ray powder diffraction data at SPring-8, Acta Crystallogr. Sect. A 63, 43 (2007).
- [40] A. Alatas, A. H. Said, H. Sinn, G. Bortel, M. Y. Hu, J. Zhao, C. A. Burns, E. Burkel, and E. E. Alp, Atomic form-factor measurements in the low-momentum transfer region for Li, Be, and Al by inelastic x-ray scattering, Phys. Rev. B 77, 064301 (2008).
- [41] I. Endo *et al.*, Determination of Atomic Form Factor of Silicon by Means of Coherent Bremsstrahlung of 1.2-GeV Electrons, Phys. Rev. Lett. **60**, 2292 (1988).
- [42] Z. W. Lu and A. Zunger, The electronic charge distribution in crystalline silicon: comparison of ab initio theory and experiment, Acta Crystallogr. Sect. A **48**, 545 (1992).
- [43] P. Schoofs, F. Cerutti, A. Ferrari, and G. Smirnov, Monte Carlo modeling of crystal channeling at high energies, Nucl. Instrum. Methods Phys. Res., Sect. B 309, 115 (2013).
- [44] W. Scandale *et al.*, Experimental study of the radiation emitted by 180 GeV/c electrons and positrons volumereflected in a bent crystal, Phys. Rev. A 79, 012903 (2009).
- [45] M. V. Bondarenco, Coherent bremsstrahlung in a bent crystal, Phys. Rev. A 81, 052903 (2010).
- [46] M. V. Bondarenco, Next-to-leading order correction to the factorization limit of the radiation spectrum, Phys. Rev. D 96, 076009 (2017).